

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

02008.152001; AT-0033US

Application Number

101786488

Applicant(s)

Seiichiro YAGI

Filing Date

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	A1	6-10880	02/10/1994	Japan	G01S	7/50		✓
JL	A2	2001 - 229717	08/24/2001	Japan	F21S	8/12		✓
JL	A3	2002 - 219993	08/06/2002	Japan	B60Q	1/02		✓
JL	A4	2002 - 219994	08/06/2002	Japan	B60Q	1/02		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

JL	A5	Patent Abstracts of Japan; Publication No. 2001-229717 dated 08/24/2001 (1 pg.)
JL	A6	Patent Abstracts of Japan; Publication No. 2002-219993 dated 08/06/2002 (1 pg.)

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Patent Abstracts of Japan; Publication No. 2002-219994 dated 08/06/2002 (1 pg.)

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